INFORMATION DISCLOSURE CITATION	Attorney Docket No.: 46884-5519 (232060)	Serial No.: 10/594,907
(Use several sheets if necessary)	Applicants Takeshi SAKAMOTO et al.	Page 1 of 1
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U.S. PATENT DOCUMENTS

*Examiner Initial		Document Number	Date	Name	Class	Sub Class	Filing Date

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Sub Class	Translation YES	NO

OTHER DOCUMENTS

(Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.) date, page(s), volume-issue number(s), publisher, city and/or country where published.)

		K. HAYASHI; "Inner Glass Marking by Harmonics of Solid-State Laser", Proceedings of 45th Laser Materials Processing Conference, Dec. 1998, pgs. 23-28.
		K. MIURA et al., "Formation of Photo-Induced Structures in Glasses with Femtosecond Laser", Proceedings of 42nd Laser Materials Processing Conference, Nov. 1997, pgs. 105-111.
		T. SANO et al., "Evaluation of Processing Characteristics of Silicon with Picosecond Pulse Laser", Preprints of the National Meeting of Japan Welding Society, No. 66, April 2000, pgs 72-73 (with at least partial English translation).

Examiner	Date Considered

Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.